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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/705,251	11/12/2003	Takamitsu Higuchi	Q78440	3192
23373 7	7590 10/20/2005		EXAMINER	
SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W.		337	DOUGHERTY, THOMAS M	
SUITE 800	LVANIA AVENUE, N.	·w.	ART UNIT	PAPER NUMBER
WASHINGTO	N, DC 20037		2834	

DATE MAILED: 10/20/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	η'
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Office Action Symmony	10/705,251	HIGUCHI ET AL.	
Office Action Summary	Examiner	Art Unit	
	Thomas M. Dougherty	2834	
The MAILING DATE of this communication ap	ppears on the cover sheet with th	e correspondence address	
A SHORTENED STATUTORY PERIOD FOR REPI WHICHEVER IS LONGER, FROM THE MAILING I  - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period.  - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the maili earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICAT .136(a). In no event, however, may a reply bd will apply and will expire SIX (6) MONTHS for te, cause the application to become ABANDO	ION. e timely filed rom the mailing date of this communic DNED (35 U.S.C. § 133).	
Status			
<ol> <li>Responsive to communication(s) filed on 27.</li> <li>This action is FINAL.</li> <li>Since this application is in condition for allows closed in accordance with the practice under</li> </ol>	is action is non-final. ance except for formal matters,		s is
Disposition of Claims			
4)  Claim(s) 1-83 is/are pending in the application 4a) Of the above claim(s) is/are withdra 5)  Claim(s) is/are allowed. 6)  Claim(s) is/are rejected. 7)  Claim(s) is/are objected to. 8)  Claim(s) 1-83 are subject to restriction and/or Application Papers	ewn from consideration.  Telection requirement.		
9)☐ The specification is objected to by the Examin	•		
10)☐ The drawing(s) filed on is/are: a)☐ ac			
Applicant may not request that any objection to the			24(4)
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E	•	· ·	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreig  a) All b) Some * c) None of:  1. Certified copies of the priority document  2. Certified copies of the priority document  3. Copies of the certified copies of the priority document  application from the International Bureat  * See the attached detailed Office action for a list	nts have been received. nts have been received in Applic ority documents have been rece au (PCT Rule 17.2(a)).	eation No eived in this National Stage	
Attachment(s)  1) \( \sum \) Notice of References Cited (PTO-892)  2) \( \sum \) Notice of Draftsperson's Patent Drawing Review (PTO-948)	4)		
Notice of Draitsperson's Faterit Drawing Review (F10-946)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date		al Patent Application (PTO-152)	

## **DETAILED ACTION**

## Response to Arguments

The applicants' response to the restriction requirement has been carefully considered. As a result, the Examiner has reconsidered the requirement, again in light of the claims. The claims define a broad array of inventions, including methods of making piezoelectric and ferroelectric devices of three or four layers on a substrate, as well as piezoelectric and ferroelectric device structures of three or four layers on a substrate. Further dividing the above inventions are those in which either the piezoelectric or ferroelectric layer, the bottom electrode layer and the intermediate (if present) are made by an ion beam assist method of irradiation which further may include a process in which a sol containing the piezoelectric or ferroelectric film is applied as a coating, dried, degreased and fired. Further dividing the broad array of inventions are those in which either the piezoelectric layer or ferroelectric layer or bottom electrode layer or intermediate layer is comprised of two layers in which one is formed by the ion beam irradiation method and the other layer is formed by the continuing deposition. Further dividing the broad array of inventions are those in which either the surface on which the bottom electrode or the intermediate layer or the piezoelectric or ferroelectric layer is formed is subject to irradiation before the formation of the cited layers.

To advance the prosecution of this case the restriction is presented in terms of four major groups. The previous restriction requirement is thus withdrawn.

## Election/Restrictions

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Restriction to one of the following inventions is required under 35 U.S.C. 121:

Claims 1-13, 26-28, 32-35, 40-45, 52, 53, 55 and 56, drawn to a method of making a three layer piezoelectric or ferroelectric device, classified in class 29, subclass 25.35 and/or class 117, subclass 108.

- II. Claims 14-25, 29-31, 36-39, 46-51, 54 and 57-59, drawn to a method of making a four layer piezoelectric of ferroelectric device, classified in class 29, subclass 25.35 and/or class 117, subclass 108.
- III. Claims 60-63, 65-68, 72, 73, 77 and 80, drawn to a three layer piezoelectric or ferroelectric device, classified in class 310, subclass 365 and/or class 310 subclass 311.
- IV. Claims 64, 69-71, 74, 75, 76, 78, 79 and 81-83, drawn to a four layer piezoelectric or ferroelectric device, classified in class 310, subclass 365 and/or class 310 subclass 311.

The inventions are distinct, each from the other because of the following reasons:

Inventions of groups I and II and of groups III and IV are related as process of making and product made. The inventions are distinct if either or both of the following can be shown: (1) that the process as claimed can be used to make other and materially different product or (2) that the product as claimed can be made by another and materially different process (MPEP § 806.05(f)). In the instant case the devices can be made by other means such as by epitaxially growing each layer or by pre-forming each layer and then putting them together by adhesive or pressure, etc.

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Inventions of the respective device groups and the respective method of making groups are unrelated. Inventions are unrelated if it can be shown that they are not disclosed as capable of use together and they have different modes of operation, different functions, or different effects (MPEP § 806.04, MPEP § 808.01). In the instant case the different inventions are differently made with different components arrangements and thus will have different effects.

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Direct inquiry to Examiner Dougherty at (571) 272-2022.

tmd

October 18, 2005

Thomas M. Cougherty
TOM DOUGHERTY
PRIMARY EXAMINER